

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tipton et al.

Attorney Docket No.: NOVLP075/NVLS-

000820

Application No.: 10/672,311

Examiner: UNASSIGNED

Filed: September 26, 2003

Group: 1762

Title: METHOD OF POROGEN REMOVAL FROM POROUS LOW-K FILMS USING

**UV RADIATION** 

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on February 25, 2004 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450

Alexandria, WA 22313-1450

Signed:

Leslie Russel

### AMENDMENT TRANSMITTAL

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

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Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	37	MINUS	37	0	x 9 =	x 18 = 0.00
Independent Claims	3	MINUS	3	,o	x 43 =	x 86 = 0.00
Multiple Dependent Claim Present and Fee Not Previously Paid					\$145.00	\$290.00
			-	Total	\$	\$0.00

Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.

Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. NOVLP075).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

Jeffrey K. Weaver Reg. No. 31,314

P.O. Box 778 Berkeley, CA 94704-0778

# PE 17 700 B

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Signed:

Leslie Russell

## PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Before examination on its merits, please amend the above-identified patent application as follows:

Amendments to the Specification being on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.